

Notice of References Cited	Application/Control No. 10/537,158		Applicant(s)/Patent Under Reexamination BISCARINI ET AL.	
	Examiner Elizabeth Whitehead		Art Unit 1762	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/017272	11-2002	Chen et al.	365/151
*	B	US-6,827,979	12-2004	Mirkin et al.	427/256
	C	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

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	U	Cavallini et al., "Information Storgae Using Supramolecular Surface Patterns", January 24, 2003, Science Magazine, Vol. 299, p. 531.
	V	Cavallini et al., "Conformational Self-Recognition as the Origin of Dewetting in Bistable Molecular Surfaces", October 11, 2001, American Chemical Society, J. Phys. Chem. B 2001, 105, 10826-10830.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.